

**Search Notes**

Application/Control No.

10/709,975

Examiner

Urszula M. Cegielnik

Applicant(s)/Patent under  
Reexamination

BEAN, RON M.

Art Unit

3711

**SEARCHED**

Class	Subclass	Date	Examiner
446	207- 209	8/4/06	UMC
↓	397	↓	↓
↓	193	↓	↓
↓	418	↓	↓

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR